



JPV

PATENT
Customer No. 22,852
Attorney Docket No. 04329.2306

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yoshio Ozawa, et al.) Group Art Unit: 2823
Application No.: 09/559,757) Examiner: Pham, Thanh V.
Filed: April 27, 2000)
For: METHOD OF MANUFACTURING)
A SEMICONDUCTOR DEVICE)
USING AN OXIDATION)
PROCESS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed August 11, 2004, with a period for response extending through November 12, 2004 (November 11th being a Federal Holiday), please amend the application as follows. Applicants request the Examiner's reconsideration in view of the remarks that follow:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks begin on page 7 of this paper.